

Notice of References Cited	Application/Control No. 10/790,401	Applicant(s)/Patent Under Reexamination LI ET AL.	
	Examiner M. Alexandra Elve	Art Unit 1725	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,856,712	02-2005	Fauver et al.	385/12
*	B	US-6,951,627	10-2005	Li et al.	264/400
*	C	US-2004/0188393	09-2004	Li et al.	219/121.7
*	D	US-2005/0194365	09-2005	Li, Ming	219/121.68
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Li et al.; "Nanostructuring in submicron-level waveguides with femtosecond laser pulses"; October 15, 2002; Elsevier (Optics Communications North-Holland) vol. 212, no. 1-3, 159-163.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.